

# LED Pattern Projector / KLP-35



Lens interface: Nikon F mount

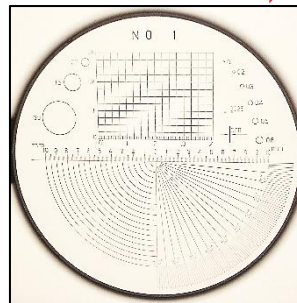
\*\* This product is a prototype for exhibition showing, the design specifications are subject to change without prior notice.

## Pattern projection for structured ray, light-section method.

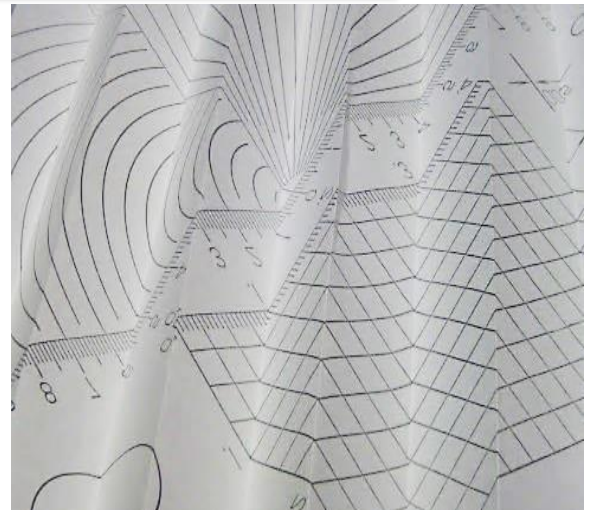


Rough surface object

Projected to a undulating object

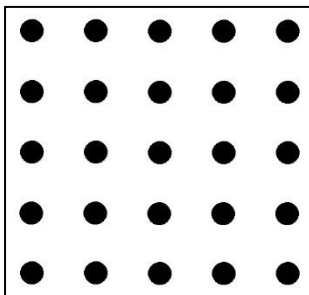


Project above indicated pattern

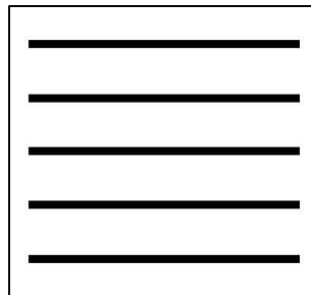


Identify the surface by the pattern

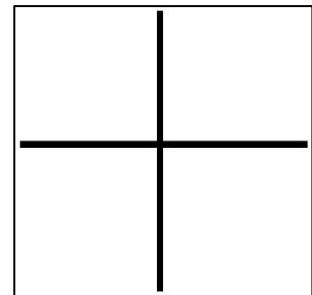
## Replaceable any dedicated pattern.



Dots



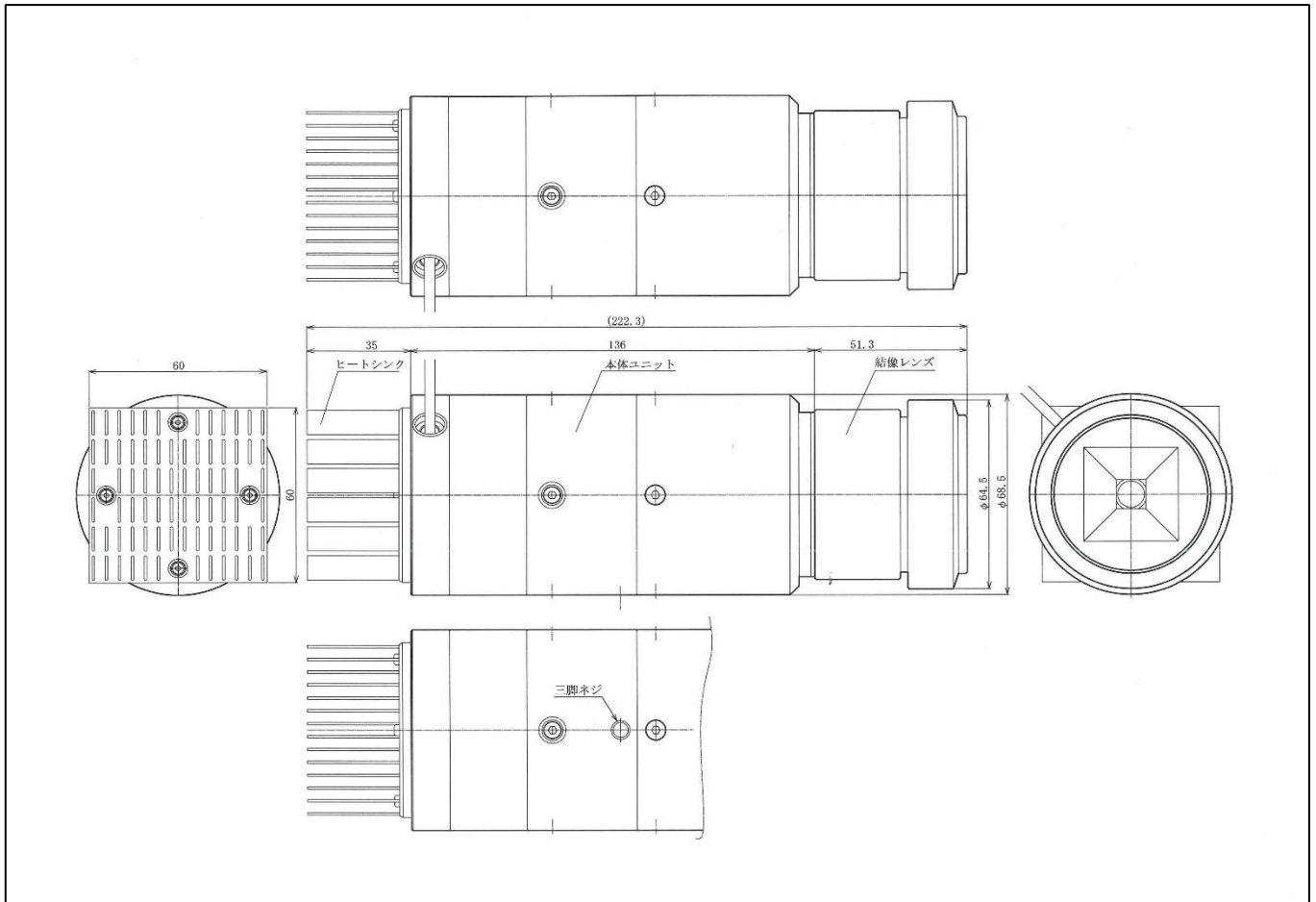
Line



Cross

Use a long life LED light source(1 chip 20W class)

## External View



## Specifications

Outer diameter:  $\phi 68.6$

Weight: 800g

Power consumption: 20W(max.)

Lens interface: Nikon F mount

Illumination intensity: 1,000,000Lx at pattern chart surface

 **NACACUE CORP.**

Higashitsuchikawa-cho, Kuze, Minami-ku,  
Kyoto 601-8204, JAPAN.

Tel. +81-75-934-4178

Tax. +81-75-934-1870

<https://www.nacacue.co.jp>